PTO-1449 Information Disclosure Citation in an Application				Application No. Applicant(s)					
				10/748, 952 Docket Number					
					Group Art Unit	Filing Date			
an Appreacion				TI-37647 (032350.B584)	2874 Decemb		er 30, 2003		
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PH	A	5,442,414	08/15/1995	Janssen et al.	353	98	05/10/1994		
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EXAMINER
Phan T. H. Palmer
Considered, 10/31/2005 EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

DATE CONSIDERED